

Notice of References Cited	Application/Control No. 10/788,571	Applicant(s)/Patent Under Reexamination SHIH ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,527,434	06-1996	Hamnett et al.	205/331
	C	US-			
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	I	US-			
	J	US-			
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	M	US-			

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	N	JP 60017092 A	01-1985	Japan	IHARA et al.	C25D 03/22
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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